



PATENT
Attorney Docket No. 403033/HOEGGER
Client Reference No. A 100 655 g

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

ENSINGER et al.

Application No. 10/814,590

Filed: April 1, 2004

Art Unit: 3723

Examiner: Unassigned

For: RETAINING RING FOR HOLDING
SEMICONDUCTOR WAFERS IN A
CHEMICAL MECHANICAL POLISHING
APPARATUS

PRELIMINARY AMENDMENT

U.S. Patent and Trademark Office
220 20th Street S. Customer Window, Mail Stop Amendment
Crystal Plaza Two, Lobby, Room 1B03
Arlington, VA 22202

Dear Sir:

Prior to the examination of the above-identified patent application, please enter the following amendments and consider the following remarks.

12/23/2004 NNGUYEN1 00000112 121216 10814590
01 FC:1202 350.00 DA